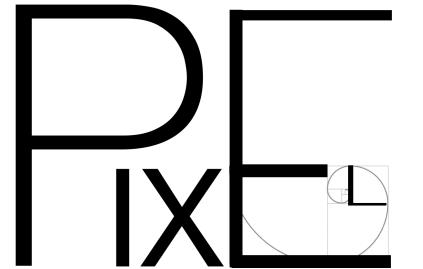
MIT Bates for ultra-light silicon pixel detectors

Gian Michele Innocenti (MIT)
MIT Heavy-ion Group

DOE review of Bates Laboratory
MIT, July 09-10, 2024

https://pixelphilab.mit.edu

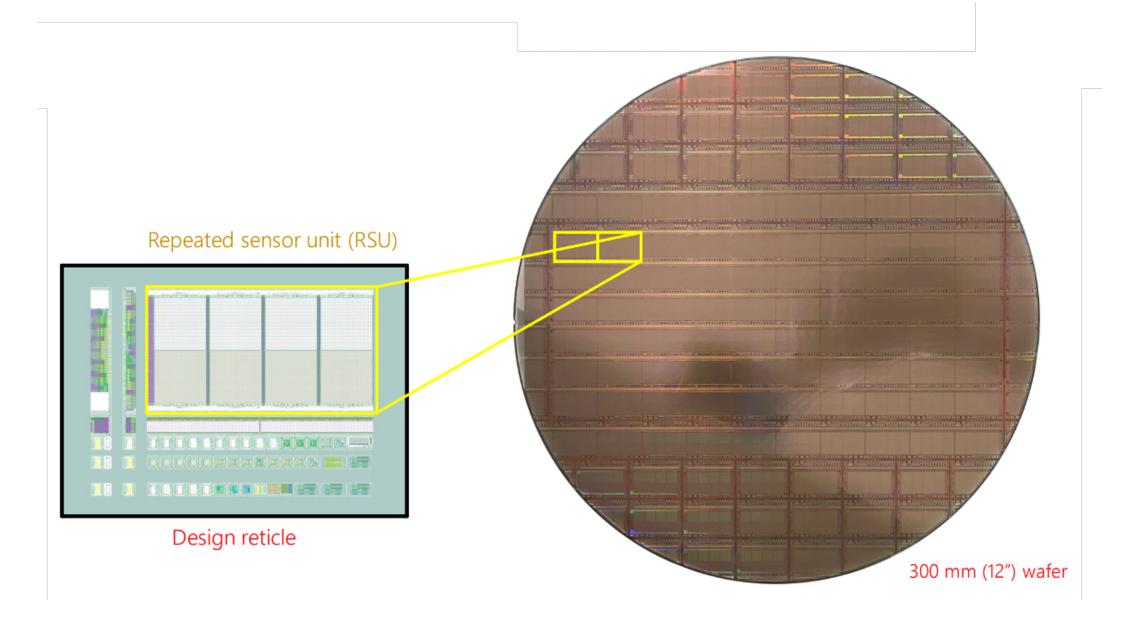


Next generation silicon detectors

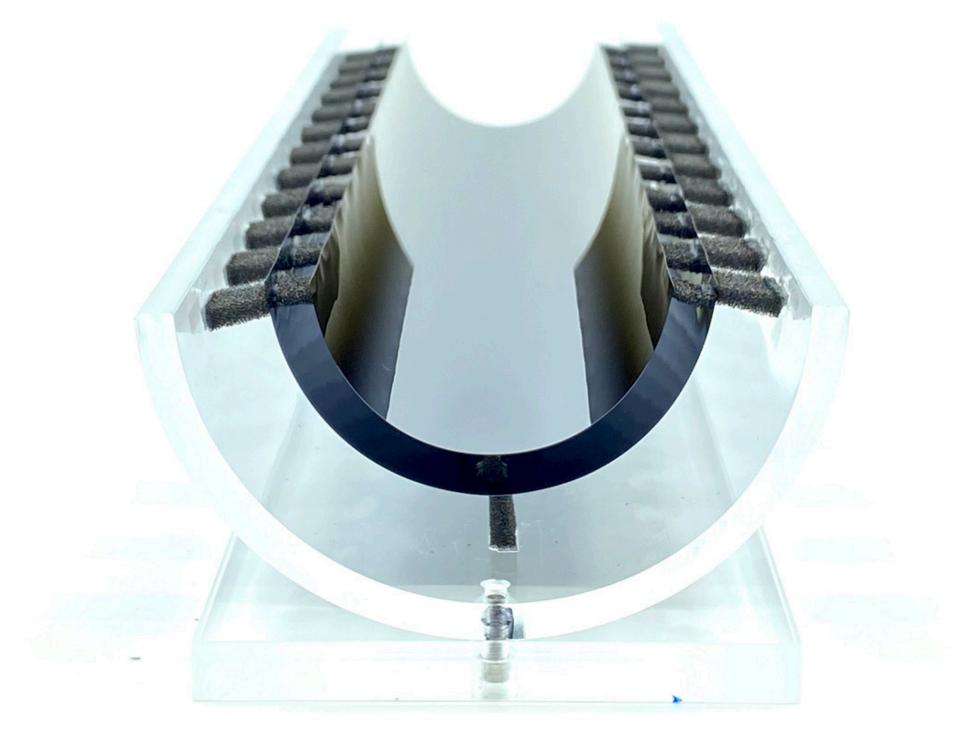
MIT PixEL φ : a new laboratory to exploit a new cutting-edge silicon pixel technology:

- → Ultra-light ("massless") Bendable Monolithic Active Pixels
- → most-accurate tracking detector ever built (~ micron spatial resolution)

· large sensors with "stitching" techniques



• "bendable" when thinned below ~20-40 μm

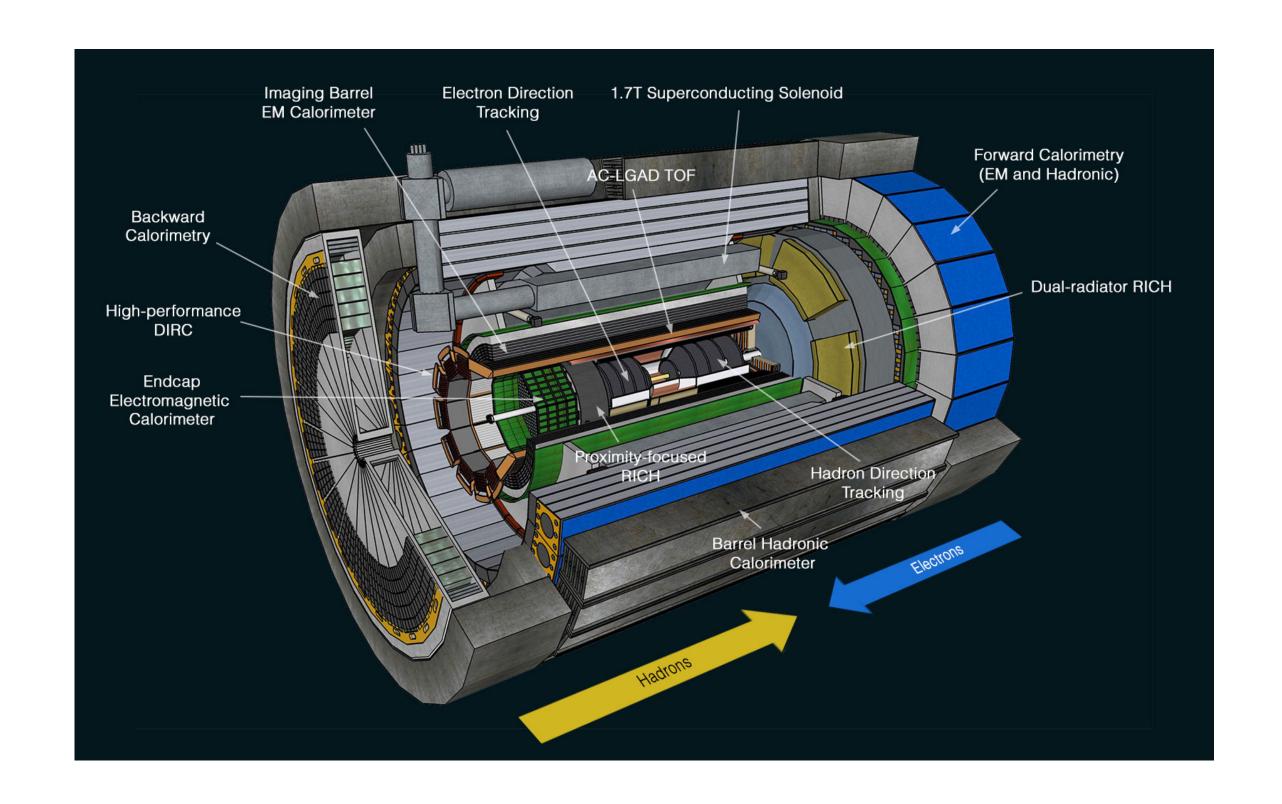


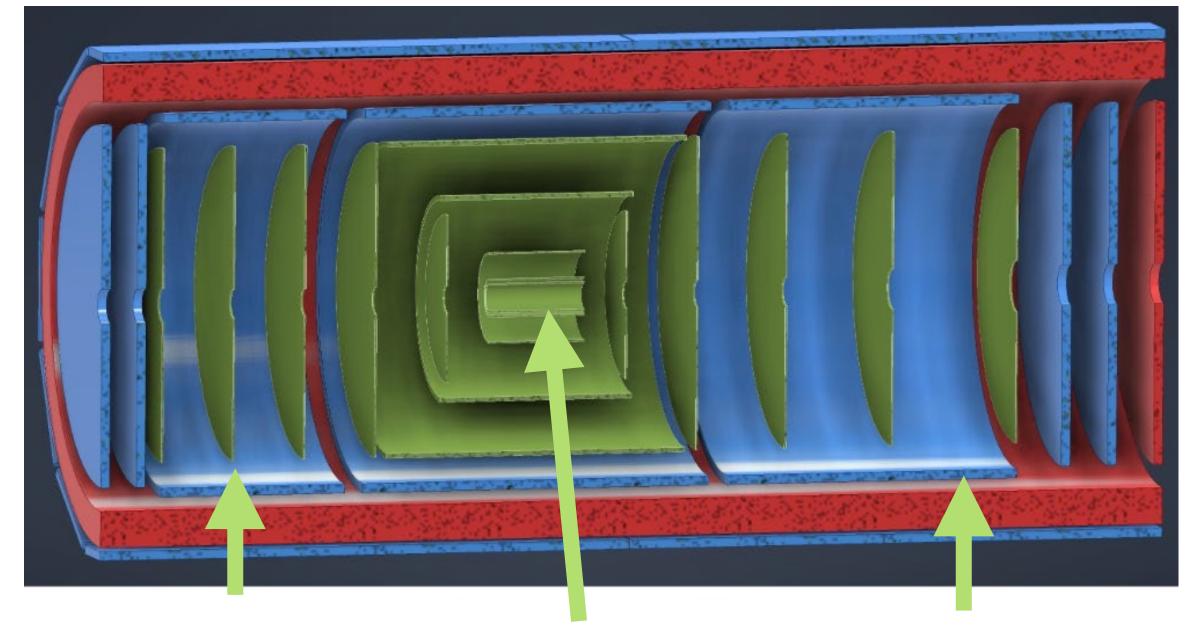
The Silicon Vertex Tracker (SVT) for ePIC@EIC is the most advanced application of stitched MAPS sensors for large-area wide-acceptance detectors

SVT for ePIC at the Electron-Ion Collider

SVT is paving the way for future large-area application of this new technology

→ unique technological challanges in terms of sensor R&D, cooling, mechanical design and integration





SVT disks SVT inner barrel SVT disks (IB)

Large-area stitched-MAPS sensors

PixEL φ at Bates: prospects beyond SVT

On-sensor AI for MAPS with hls4ml:

• noise-tagging, fast trigger and data reduction on MAPS for future HEP experiments (focus on e+e- for FCC and eA for EIC)

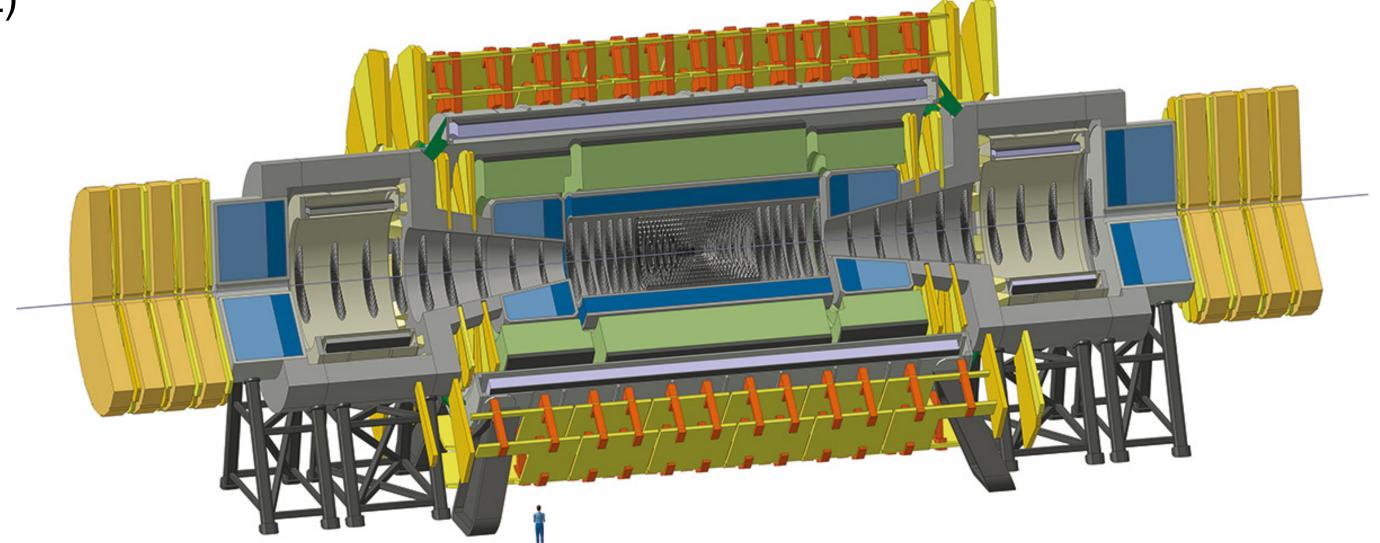


Applications in atomic physics:

e.g. detection of low-energy electrons for cold-atom physics (in collaboration with Prof. Garcia Ruiz)

Medical imaging:

online calibration of proton/ion beams for Carbon therapy

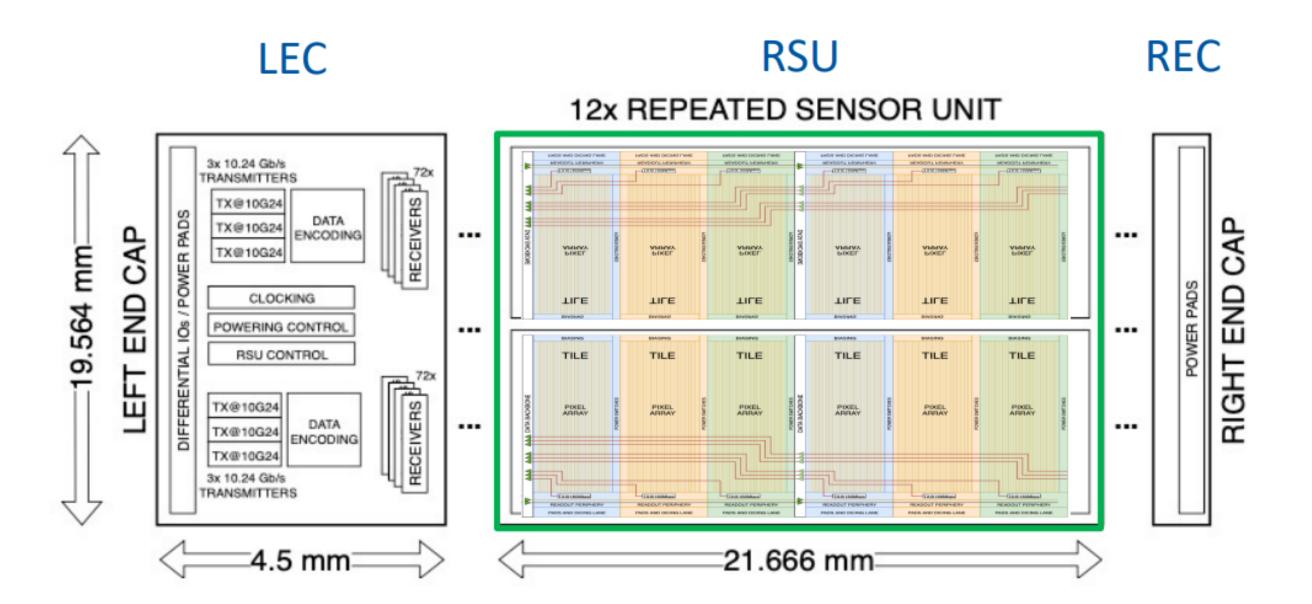


MAPS-based tracker for the Future-Collider Collider at CERN:

→ MAPS is at the core of the detector design of the future FCC detectors (2040/2050 -)

MIT PixEL ϕ : SVT contributions

Major contributions to the sensor design and testing





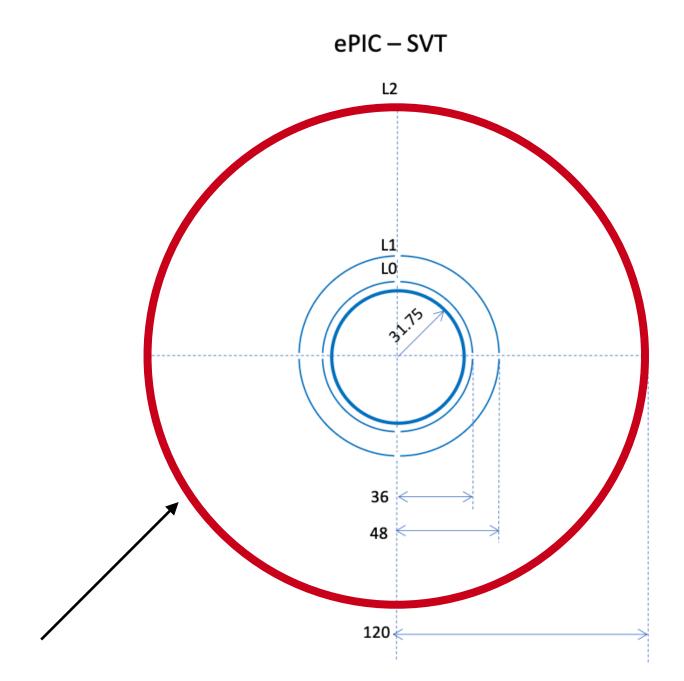
- Developing a brand new high-frequency testing strategy for large-area sensors
 - → MIT is leading the testing, characterization working group of the SVT collaboration
- Design and optimize the SVT readout strategy for service reduction

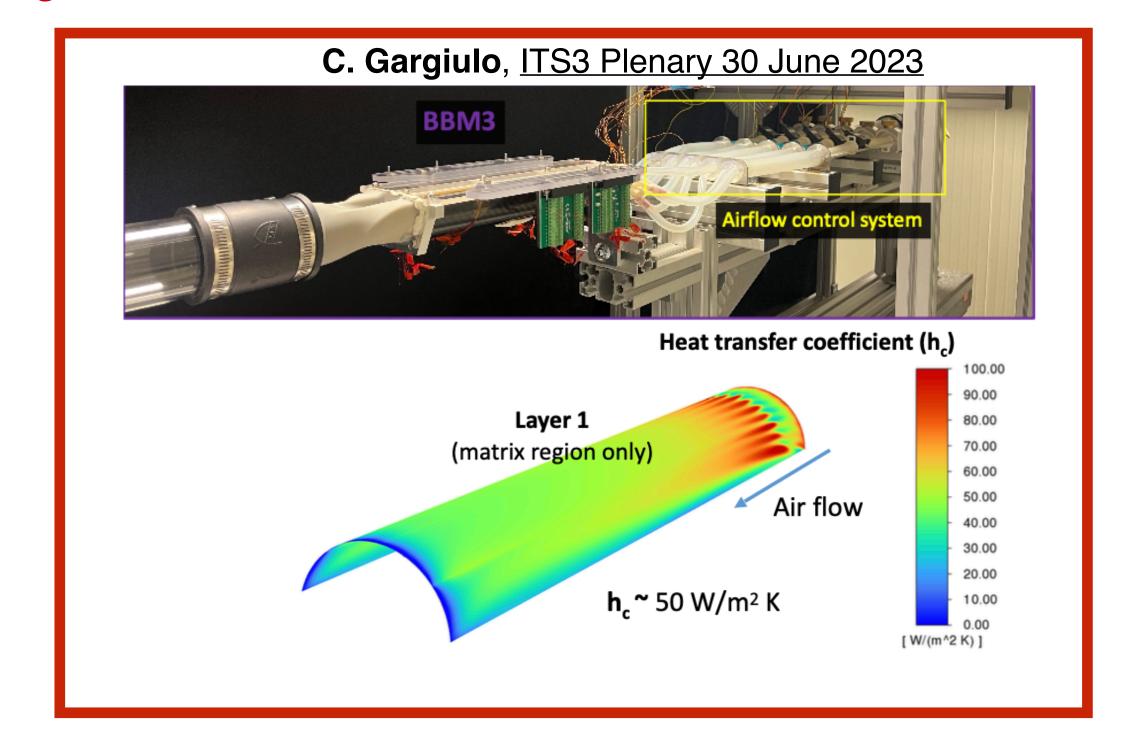
The sensor and testing activities are currently carried out at CERN to maximize the synergies with CERN MAPS experts:

→ Our plan is to move and expand the testing lab to Bates over the course of the next 2-3 years

PixEL φ at Bates: planned contributions to SVT mechanics

- · Simulation studies to characterize the mechanical properties of the SVT IB layers (ongoing)
- implement SVT geometry in ANSYS, heat-dissipation studies
- test the impact of vibrations in the presence of air flows at different speeds
- define the specifications of a wind tunnel to test the IB mechanical design, cooling, ...
- · Design of the inner-barrel geometry, support structure, and cooling
- MIT is in charge of the design and construction of the Layer2

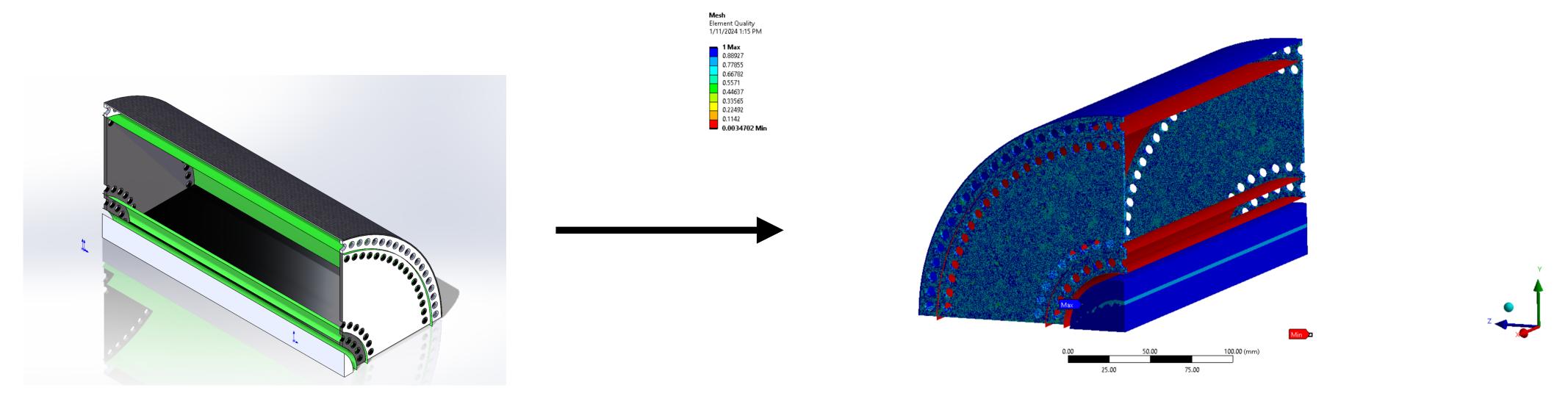




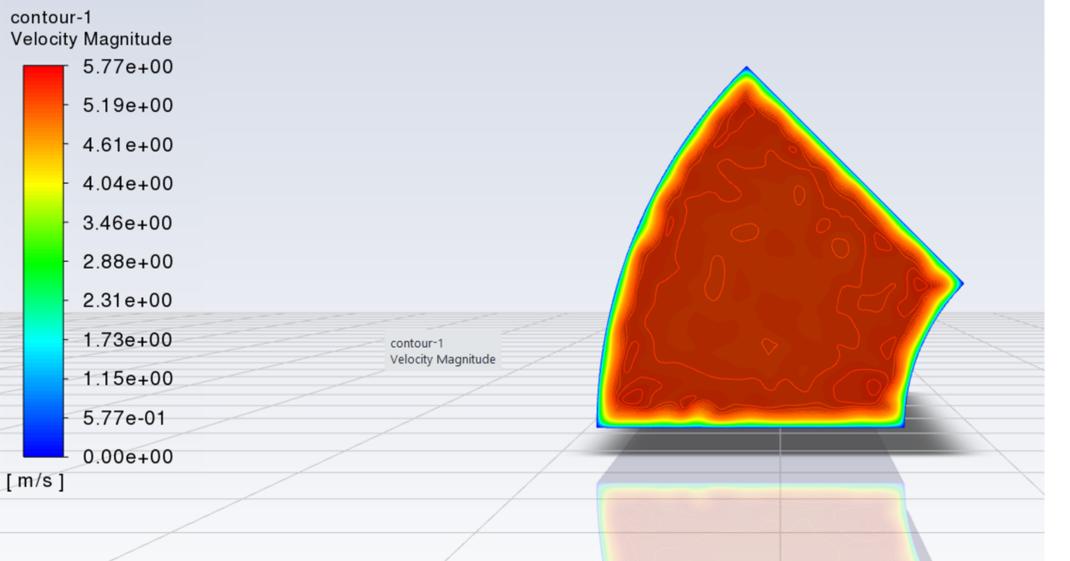
Layer2: the largest-R layer of bent MAPS sensor ever designed and constructed → a fundamental technological step towards large-area MAPS-based detectors

• Design and construction of a wind-tunnel setup to test the cooling, dissipation and mechanical properties of the SVT

PixEL φ at Bates: status of R&D activities to SVT mechanics



Implemented the current mechanical design for the SVT in SolidWorks



- Develop a fluido-dynamic simulation to model the air-based cooling of the SVT
- Currently performing a thermal study to characterize the cooling performance in presence of a realistic heat dissipation

- → preliminary studies are currently supported with in-kind Bates resources
 (Tricia Smith, Jim Kelsey)
- → SVT relies on Bates for the design and construction of the SVT L2!

PixEL ϕ at Bates: our vision

- · Bates as a centre of excellence for the R&D, design, construction and assembly of large-area sensor detectors:
- → one of the key R&D, construction, assembly sites for the EIC Silicon Vertex Tracker
- Requirements:
- Cutting-edge equipments for mechanics and electronics (bending, assembly, gluing..)
- Wind tunnels for large-area sensors
- Electronic equipment for testing (wafer probe machines, DAQ setups), bonding machine
- Spaces (clean room with vacuum systems)
- Timescale
- Next 6 months:
 - clean room to be refurnished
 - purchase of the bending tools
- Next year
 - development of a wind tunnel
 - purchase of mechanical equipment (e.g. Mitutoyo machine w/ alignment vacuum tools)
- Next two/three years:
 - → Move the now CERN-based test laboratory to MIT/Bates
 - → Equip the Bates-based lab for the assembly of the SVT inner tracking layers





Bates is a unique asset to expand and mantain a long-term leadership in this new technology

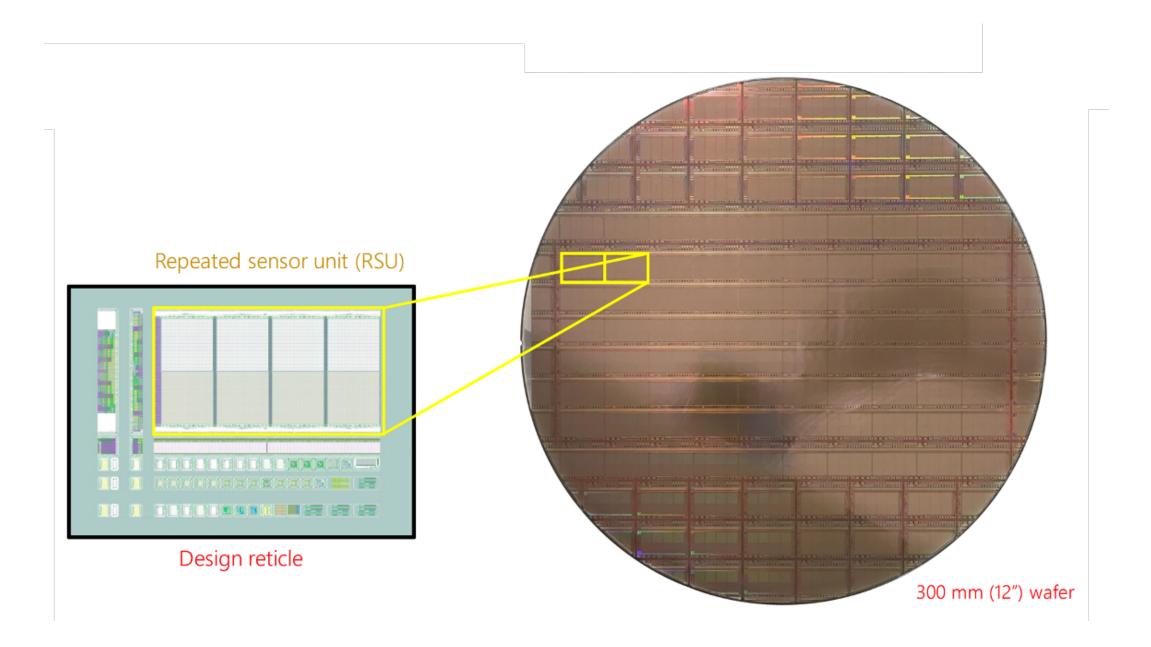
BACKUP

MIT PixEL φ : a Silicon Pixel Lab for ELementary physics at MIT

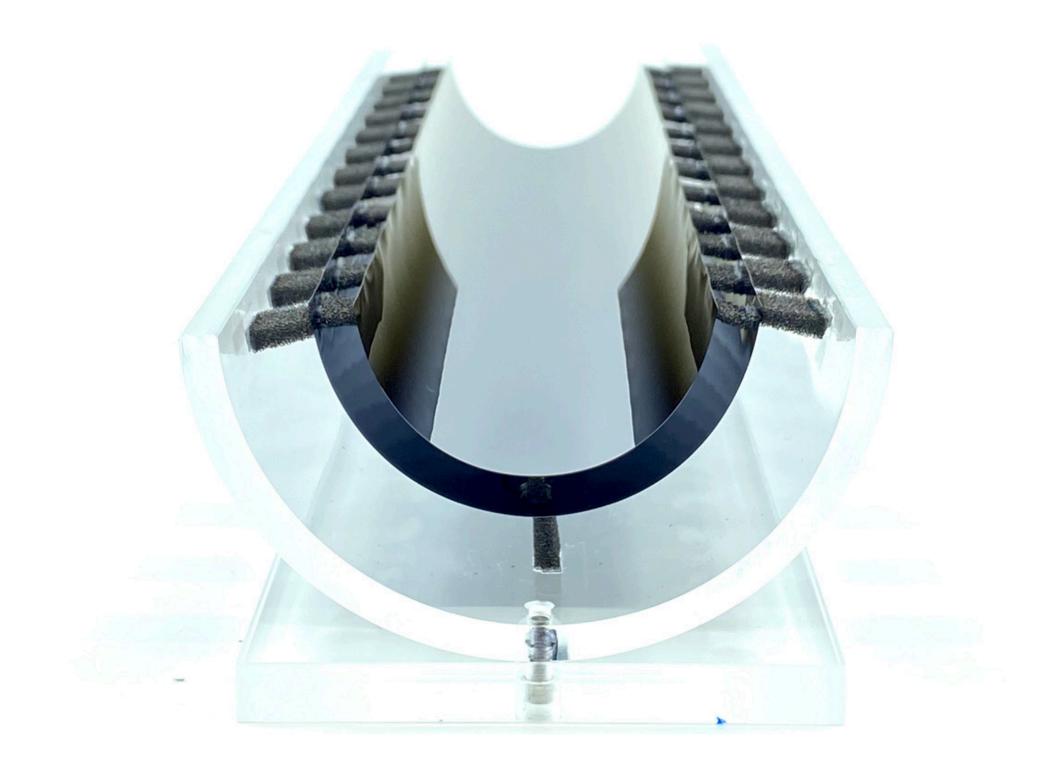
A new laboratory built at MIT to exploit a new cutting-edge silicon pixel technology:

→ Ultra-light ("massless") Bendable Monolithic Active Pixels

· large sensors with "stitching" techniques

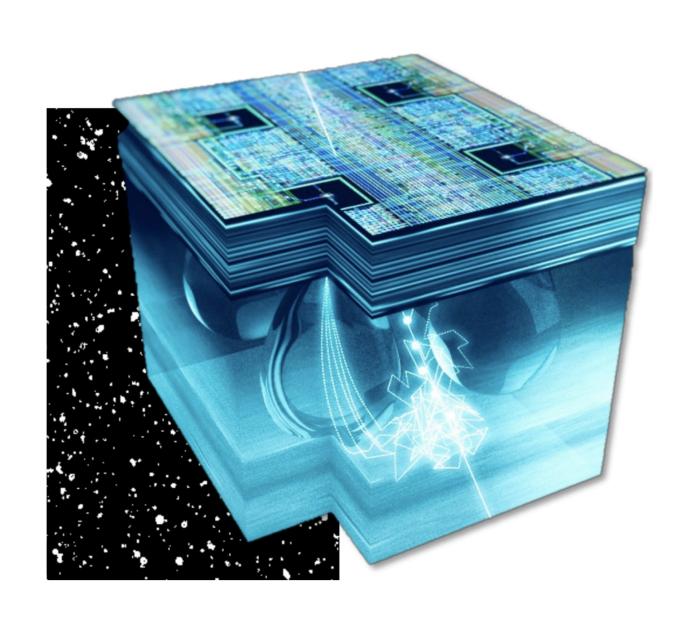


• "bendable" when thinned below ~20-40 μm

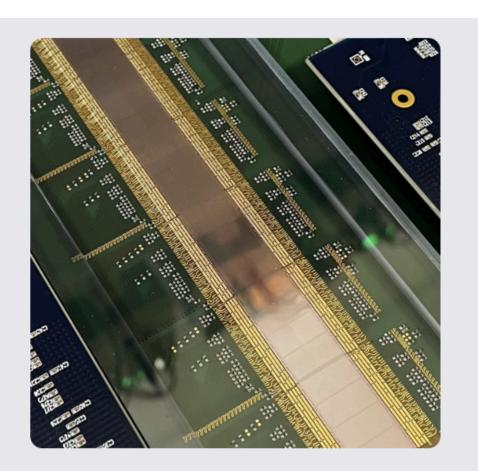


MIT PixEL φ : a Silicon Pixel Lab for ELementary physics at MIT

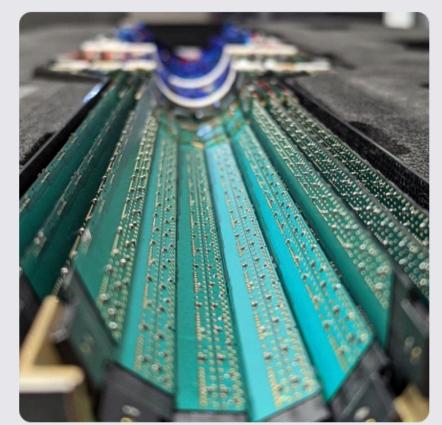
→ Next generation "stitched" MAPS technology for high-accuracy detectors for high-energy and nuclear physics



Ongoing projects



Silicon Vertex Tracker
(SVT) for the ePIC
experiment at the
Electron-Ion Collider



MVTX for the sPHENIX experiment



Artificial intelligence with FPGA for MAPS detectors

→ CERN-based MIT laboratory

Silicon detectors in the MIT heavy-ion group

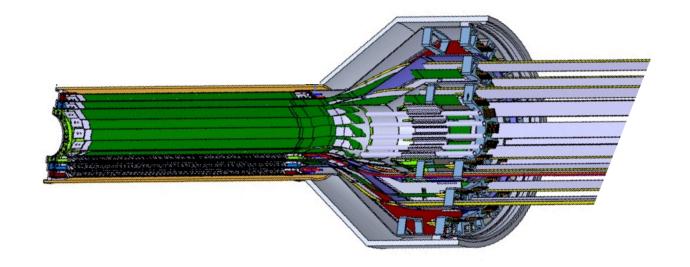
→ Almost 30 years of experience in pixels detector design, construction, commissioning

PHOBOS experiment at RHIC AC-coupled, single-sided, silicon pad for tracking, vertexing, and multiplicity

1990

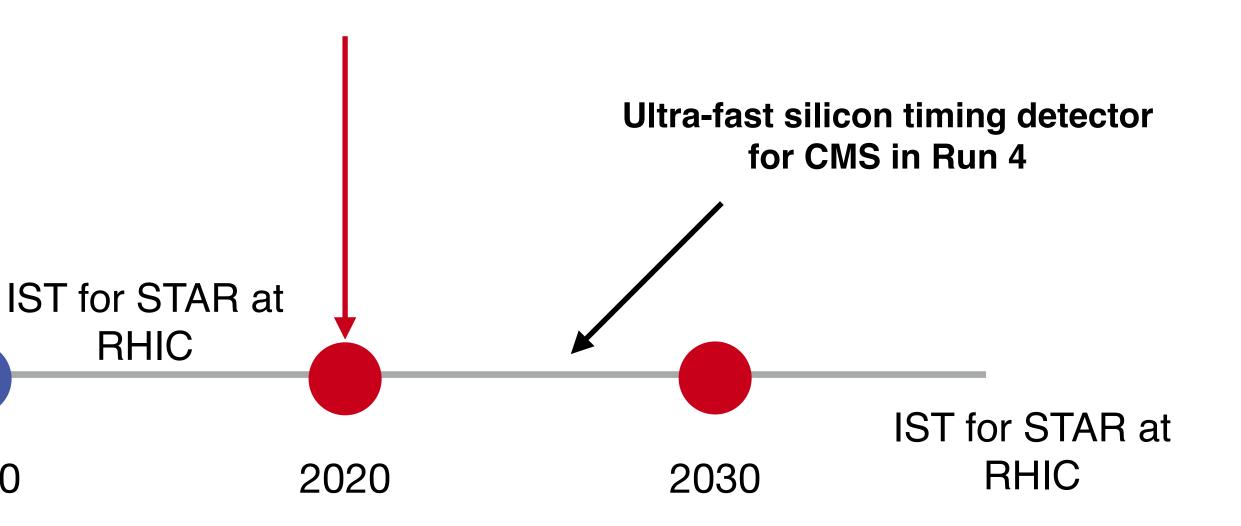


CMS tracker ("hybrid pixels") commissioning pixel and strip detectors for heavy-ion runs



Monolithic Active Vertex Tracker (MVTX) for sPHENIX with ALICE ITS2 technology

- mechanical design, cooling, and integration
- module characterization
- DCS design, installation and commissioning



SVT at the ePIC: timescale and synergies with the ITS3 project

